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CONFIRMATION NO. 4274

Bib Data Sheet

SERIAL NUMBER 10/671,552	FILING DATE 09/29/2003 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 8733.170.10	
APPLICANTS Kwang Nam KIM, Kumi-shi, KOREA, REPUBLIC OF; Gee Sung Chae, Incheon, KOREA, REPUBLIC OF; ** CONTINUING DATA ***** AC This application is a DIV of 10/330,180 12/30/2002 PAT 6,716,752 AC which is a CON of 09/977,505 10/16/2001 PAT 6,627,545 AC which is a CON of 09/430,037 10/29/1999 PAT 6,337,292 AC ** FOREIGN APPLICATIONS ***** JAPAN 1998-309237 10/29/1998 AC IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/19/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 8	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1
ADDRESS MCKENNA LONG & ALDRIDGE LLP Song K. Jung 1900 K Street, N.W. Washington, DC 20006					
TITLE Method of forming silicon oxide layer and method of manufacturing thin film transistor thereby					
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